



520.41003X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Y. KIMURA, et al.  
Serial No.: 10/019,407  
Filed: March 25, 2002  
For: POLYCRYSTALLINE SEMICONDUCTOR THIN FILM  
SUBSTRATE, MANUFACTURING METHOD OF THE  
SAME, SEMICONDUCTOR DEVICE AND ELECTRONIC  
DEVICE  
Group: 2813  
Examiner: Laura M. Schillinger

**PETITION FOR EXTENSION OF TIME**

Mail Stop: EOT  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

October 18, 2006

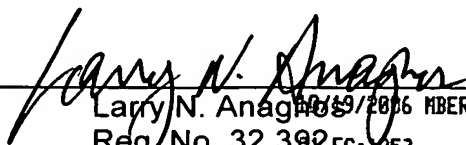
Sir:

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a response within a three-month time period subsequent to expiration of the response period set with the mailing of the new, non-Final Office Action, dated April 18, 2006. A credit card payment form in the amount of \$1,020.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (Docket No. 520.41003X00) and any excess fees credited to that account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

By   
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